INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 25, 2026

IGI Report Number	LG794657882
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.86 - 8.90 X 5.61 MM

GRADING RESULTS

Carat Weight	2.78 CARATS
Color Grade	D
Clarity Grade	VS 1
Cut Grade	EXCELLENT

ADDITIONAL GRADING INFORMATION

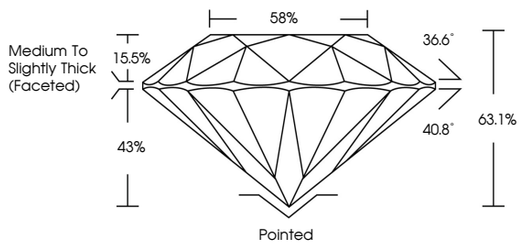
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG794657882

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG794657882

Report verification at igi.org

PROPORTIONS



www.igi.org

Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

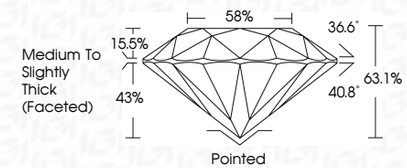
LABORATORY GROWN DIAMOND REPORT

April 25, 2026

IGI Report Number	LG794657882
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.86 - 8.90 X 5.61 MM

GRADING RESULTS

Carat Weight	2.78 CARATS
Color Grade	D
Clarity Grade	VS 1
Cut Grade	EXCELLENT



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG794657882

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

April 25, 2026
IGI Report No LG794657882
ROUND BRILLIANT
8.86 - 8.90 X 5.61 MM

Carat Weight	2.78 CARATS
Color Grade	D
Clarity Grade	VS 1
Cut Grade	EXCELLENT
Depth	63.1%
Table	58%
Girdle	Medium To Slightly Thick (Faceted)
Culet	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG794657882

Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa